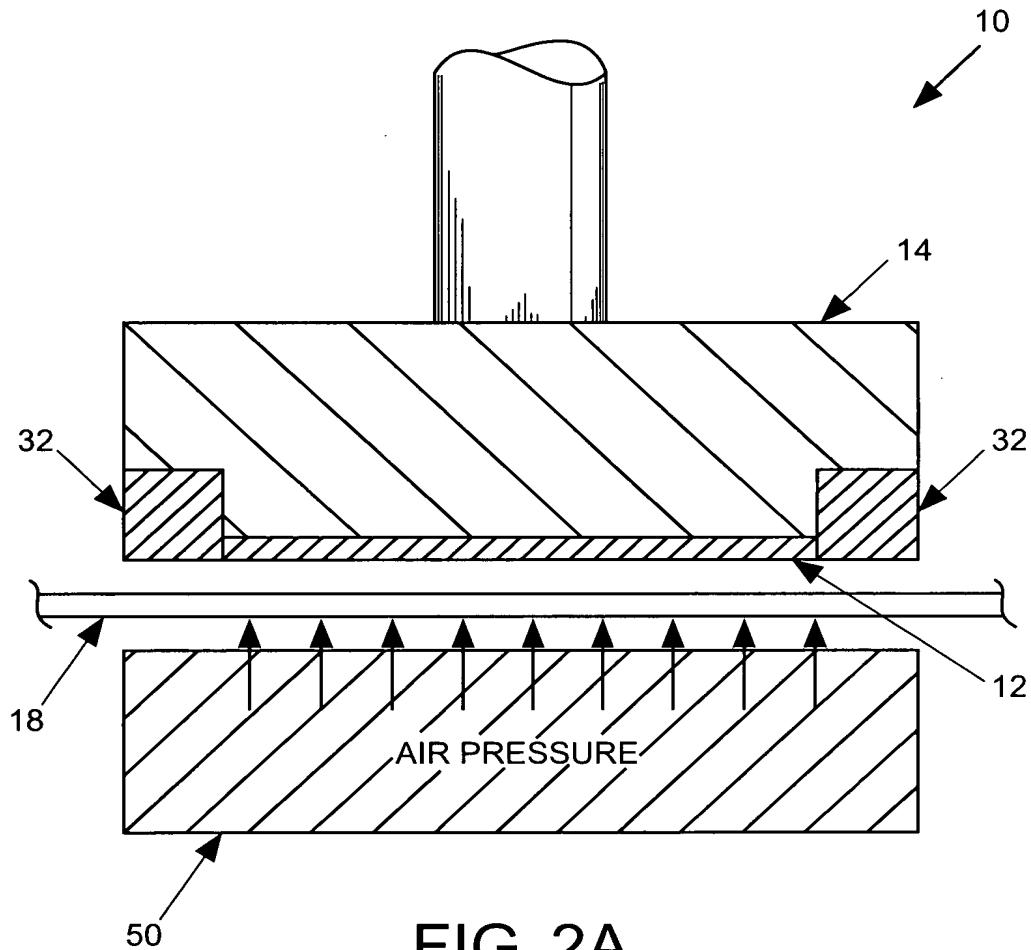


FIG. 1  
(Prior Art)



**FIG. 2A**  
**(Prior Art)**

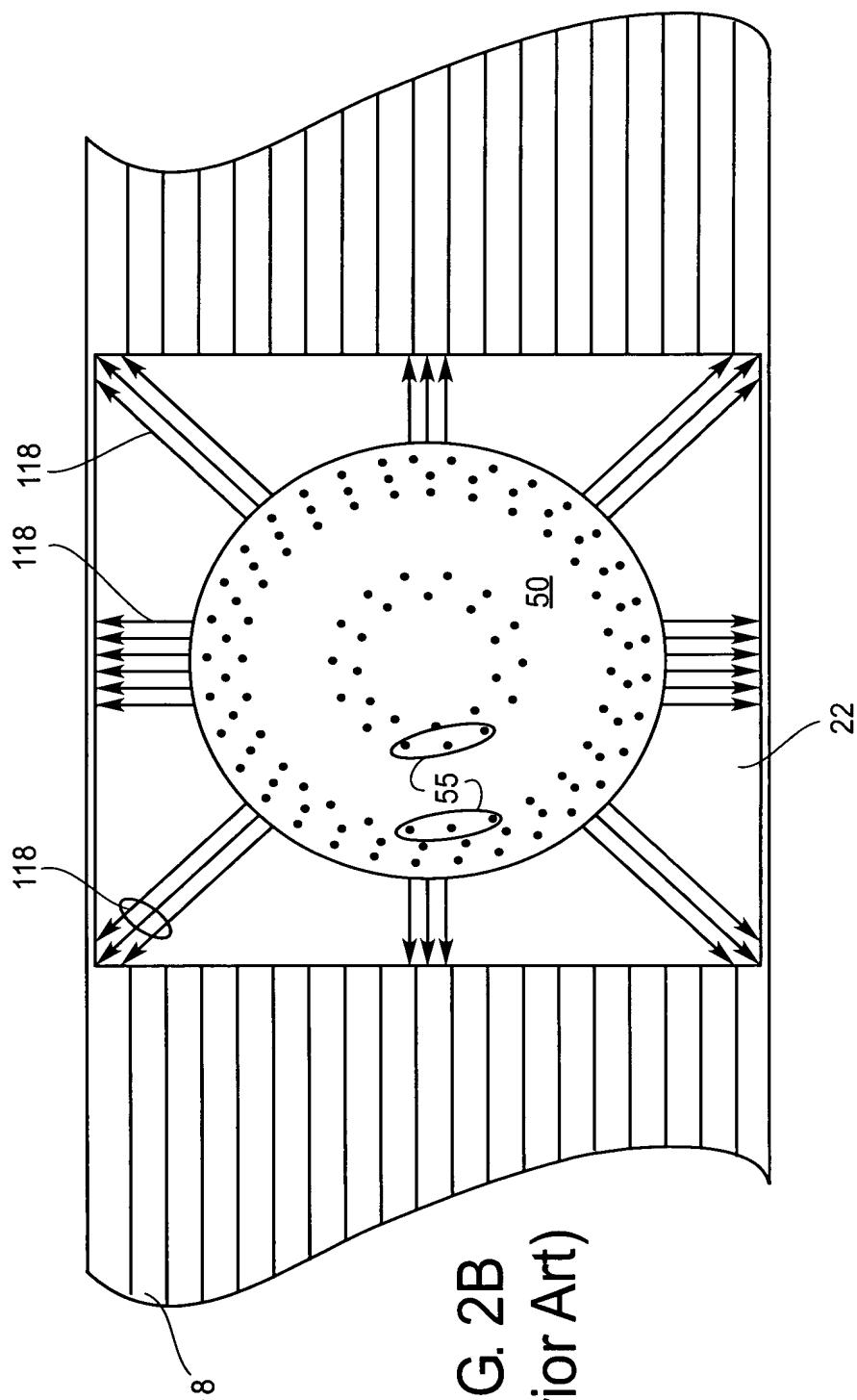


FIG. 2B  
(Prior Art)

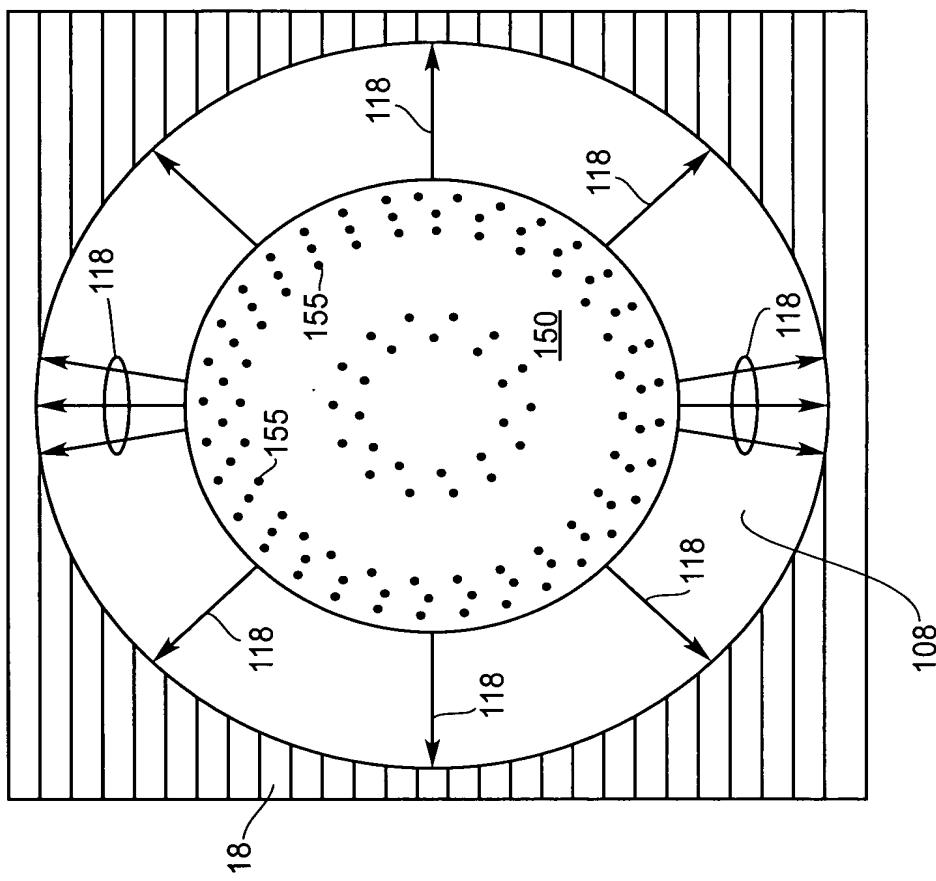


FIG. 3

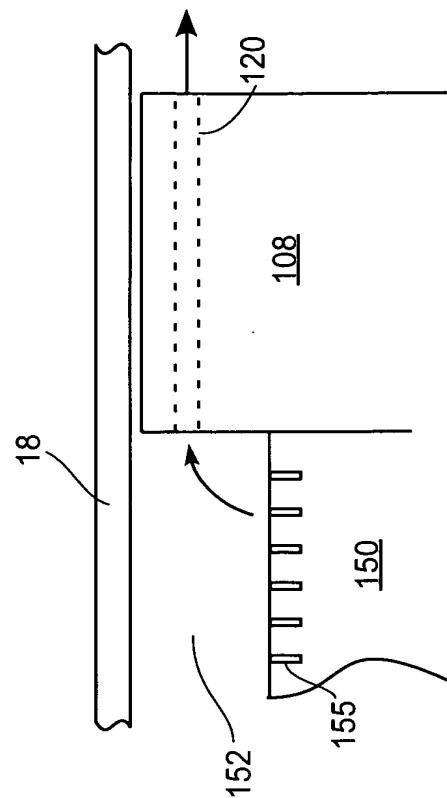


FIG. 4A-2

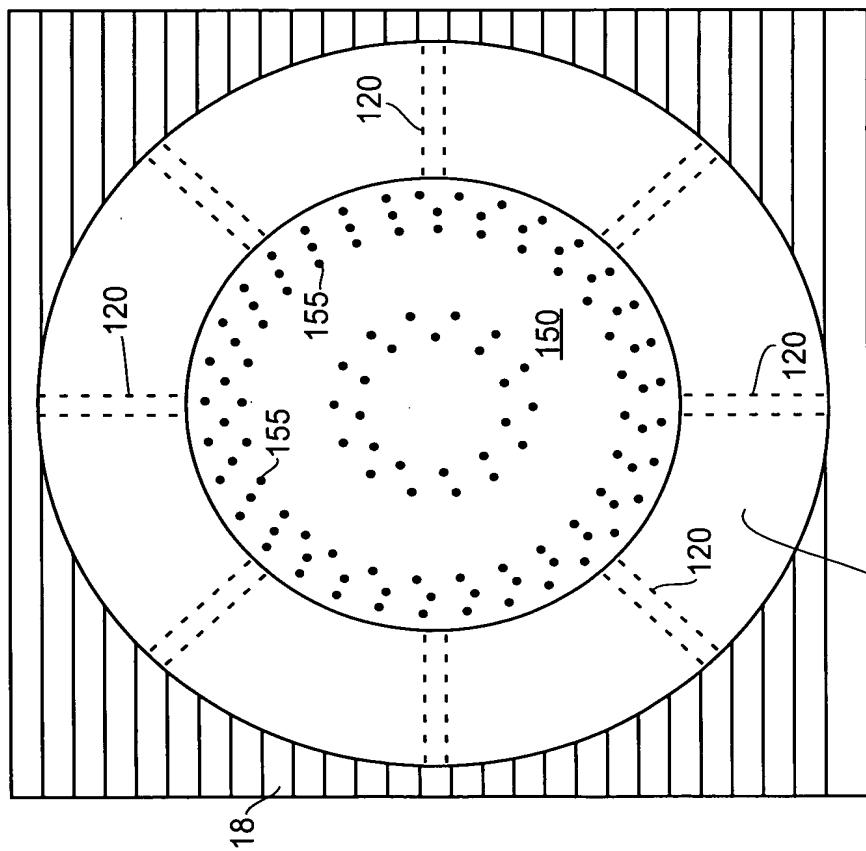


FIG. 4A-1

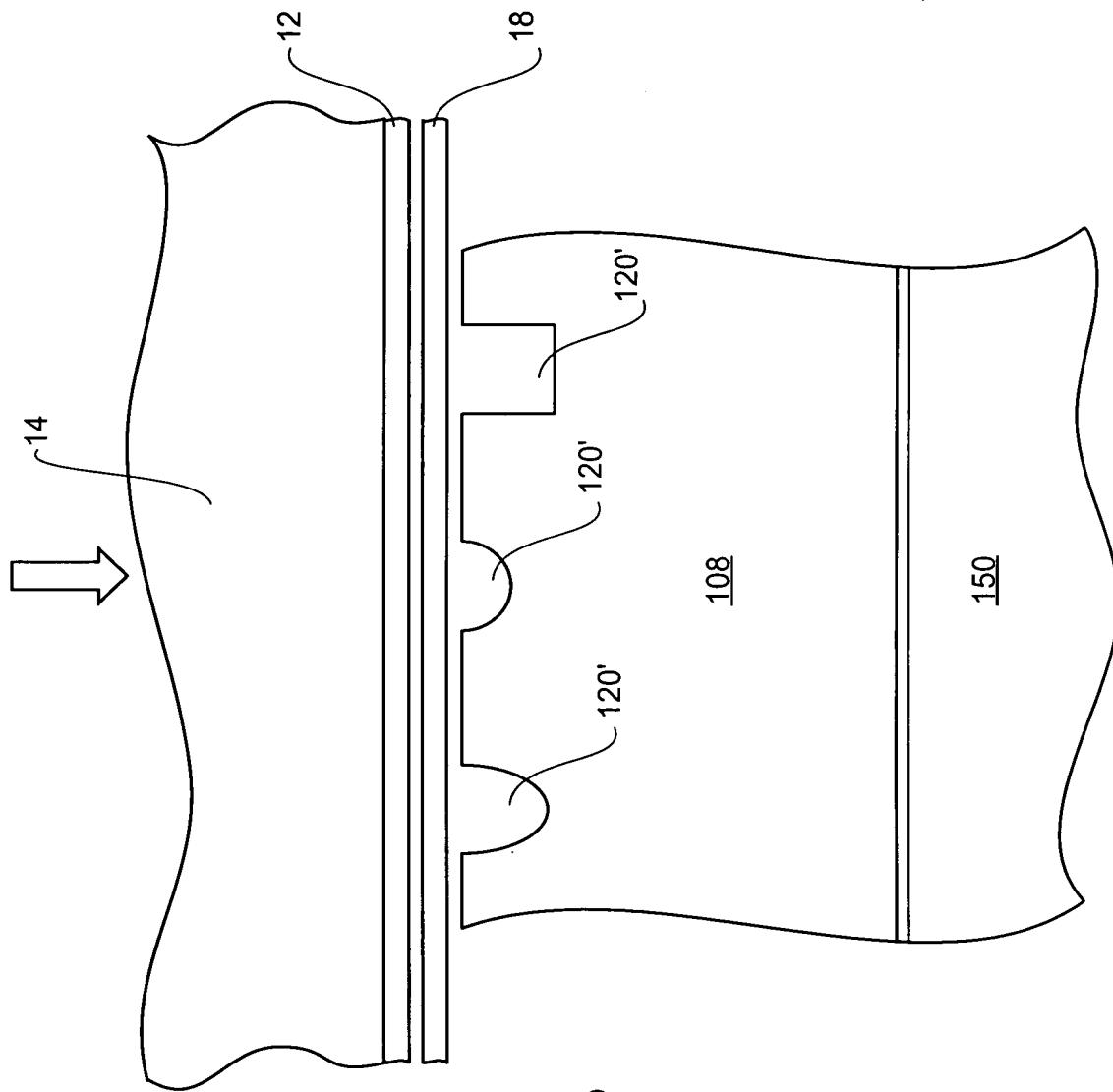


FIG. 4A-3

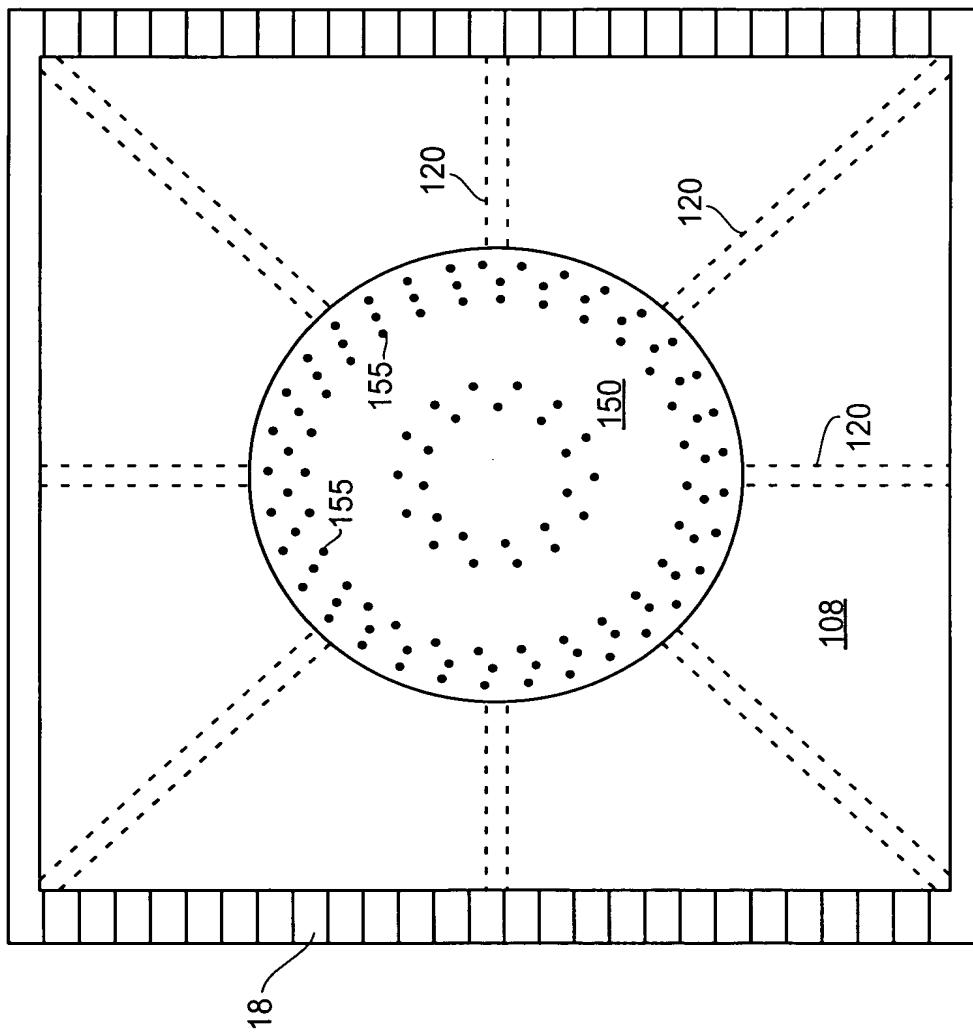


FIG. 4B

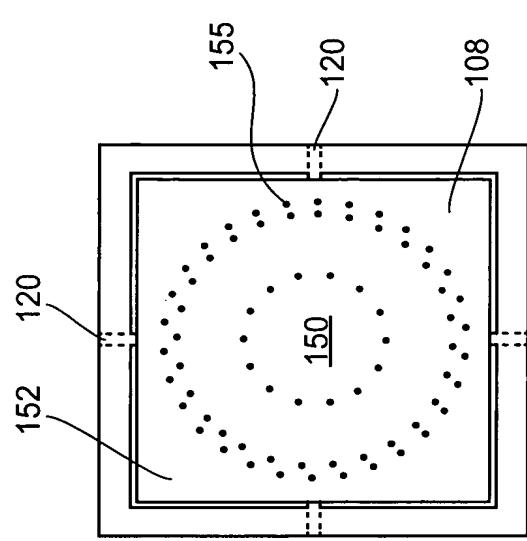


FIG. 4C-2

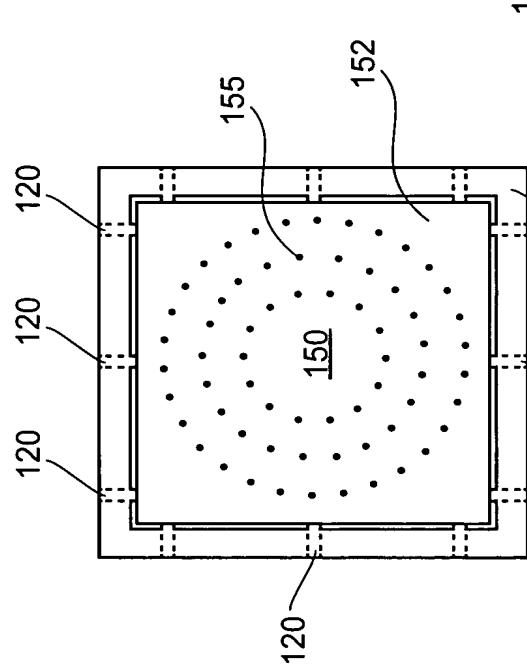


FIG. 4C-1

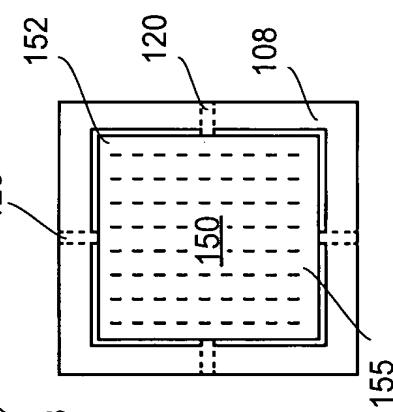


FIG. 4C-3

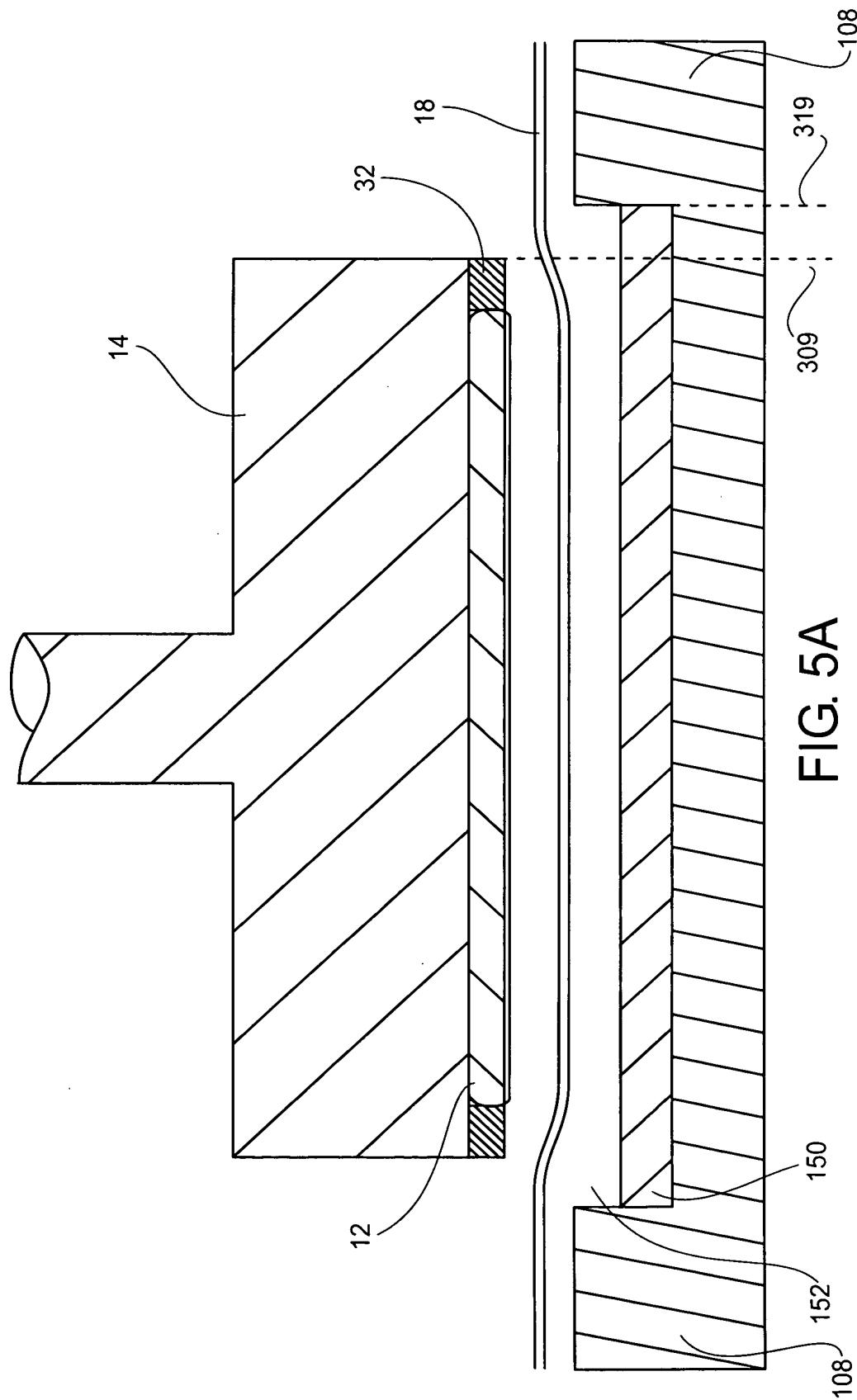


FIG. 5A

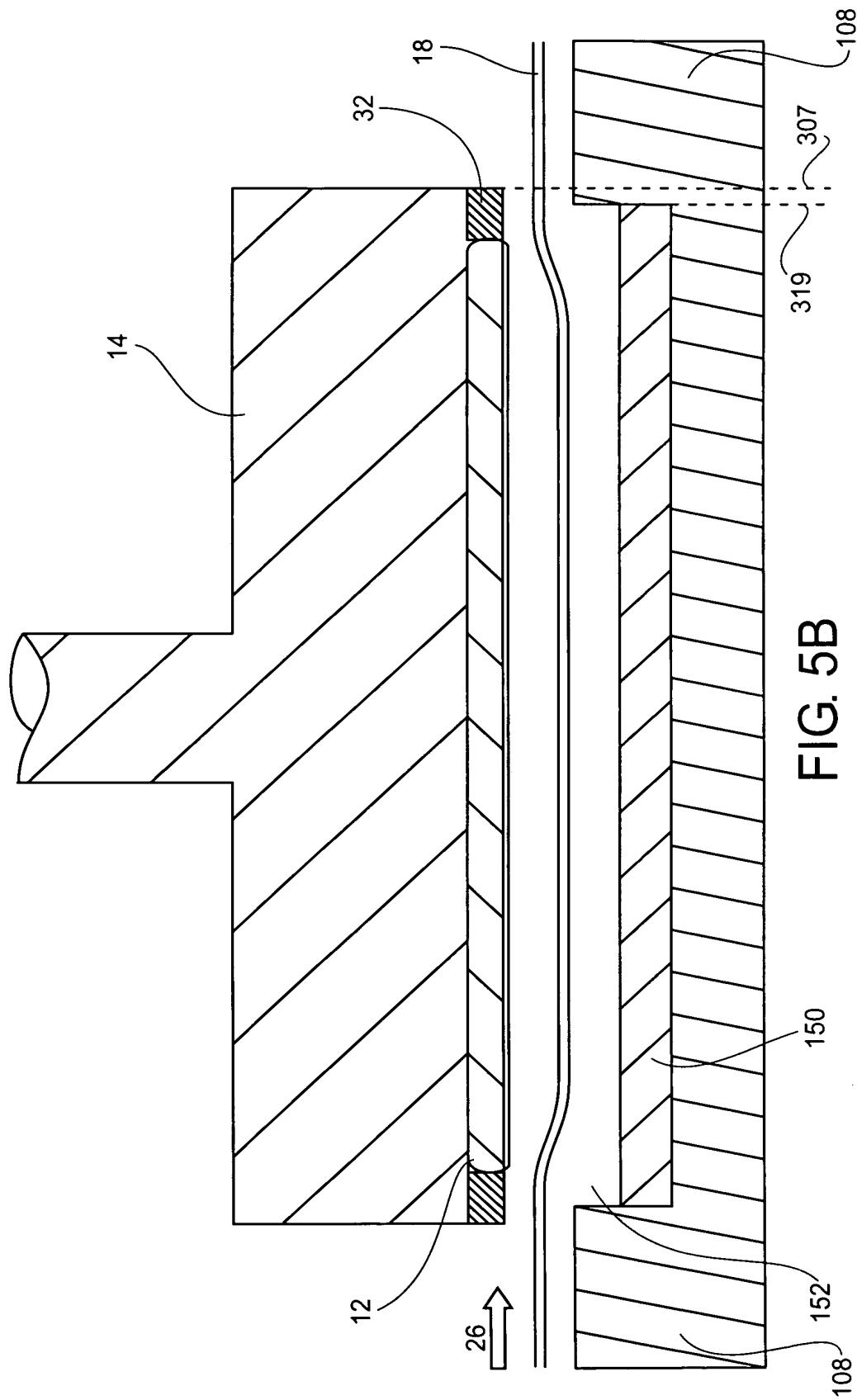


FIG. 5B

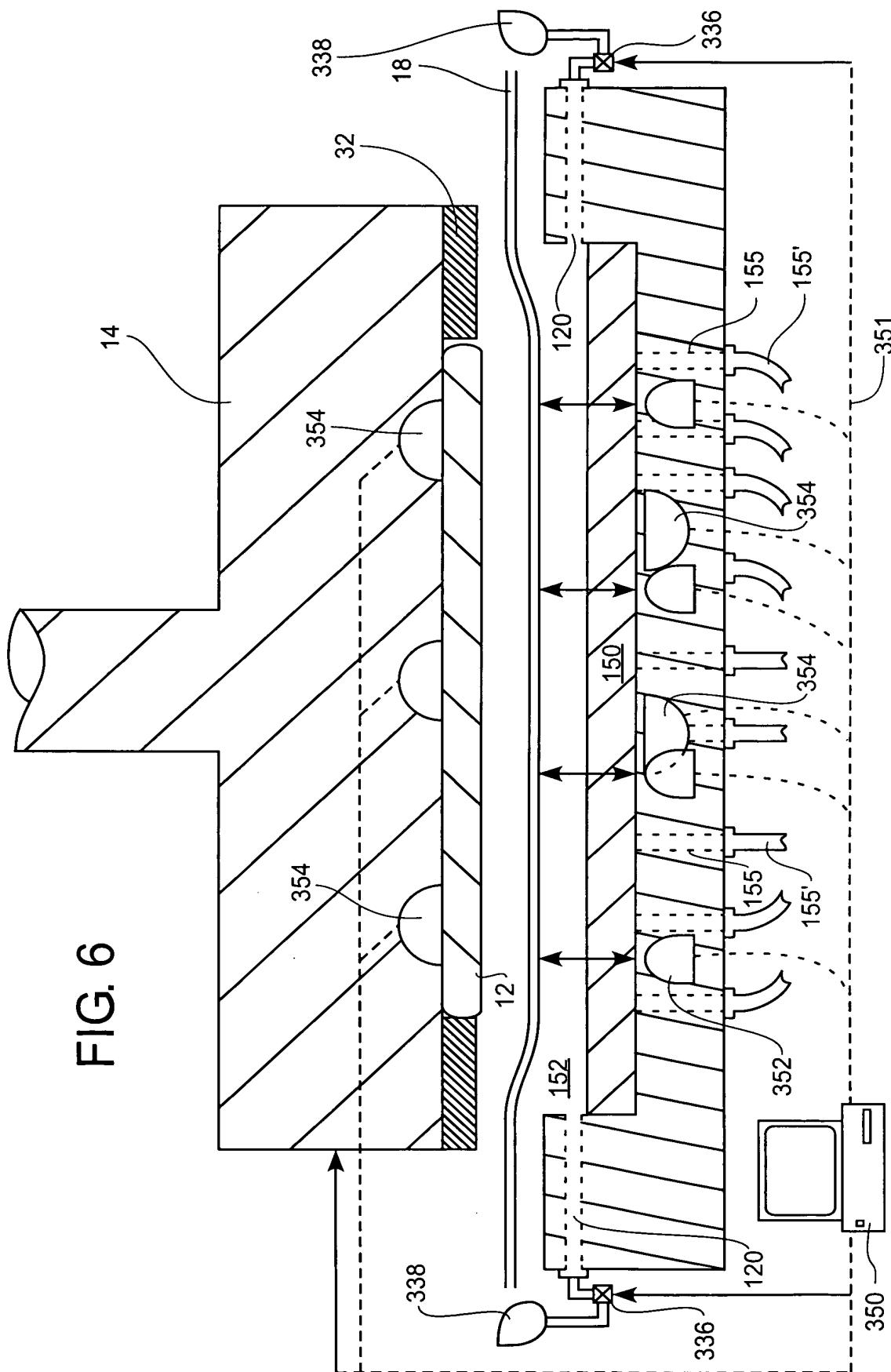
## FLUID FLOW PLATEN IN A CHEMICAL MECHANICAL POLISHING SYSTEM

Inventors: Lee et al.

Application No: 10/674,319

Docket No: LAM2P434

6  
FIG



## FLUID FLOW PLATEN IN A CHEMICAL MECHANICAL POLISHING SYSTEM

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Application No: 10/674,319

Docket No: LAM2P434

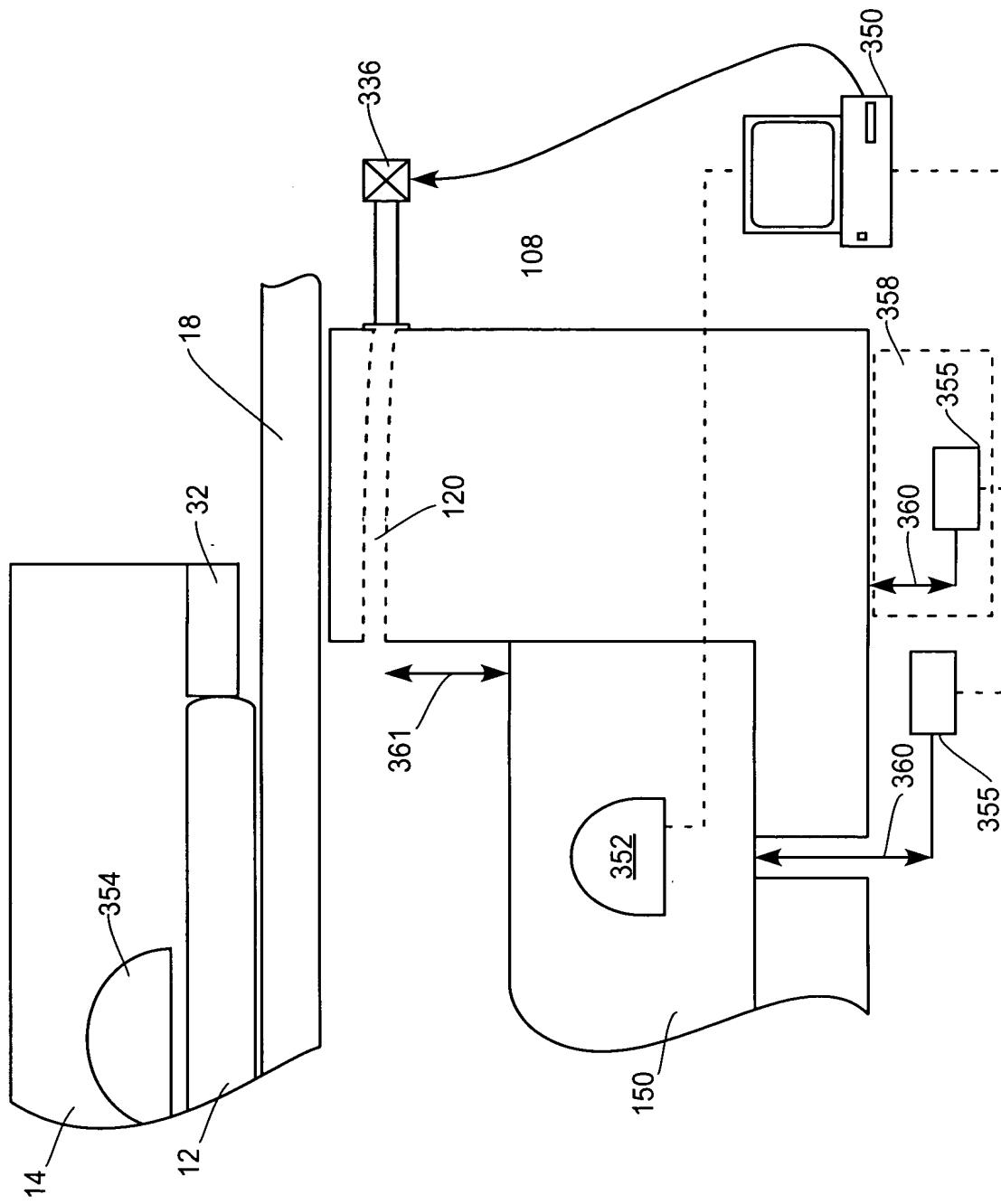


FIG 7

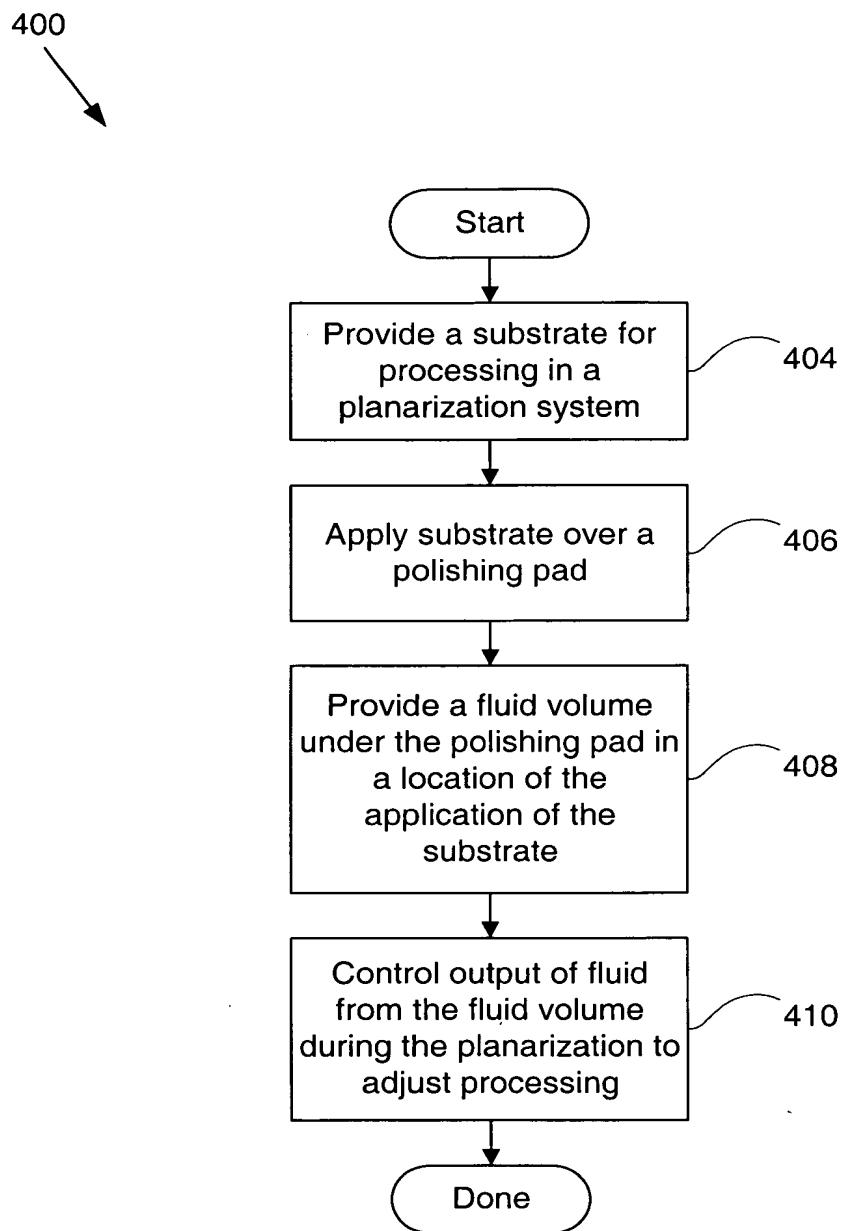


FIG. 8

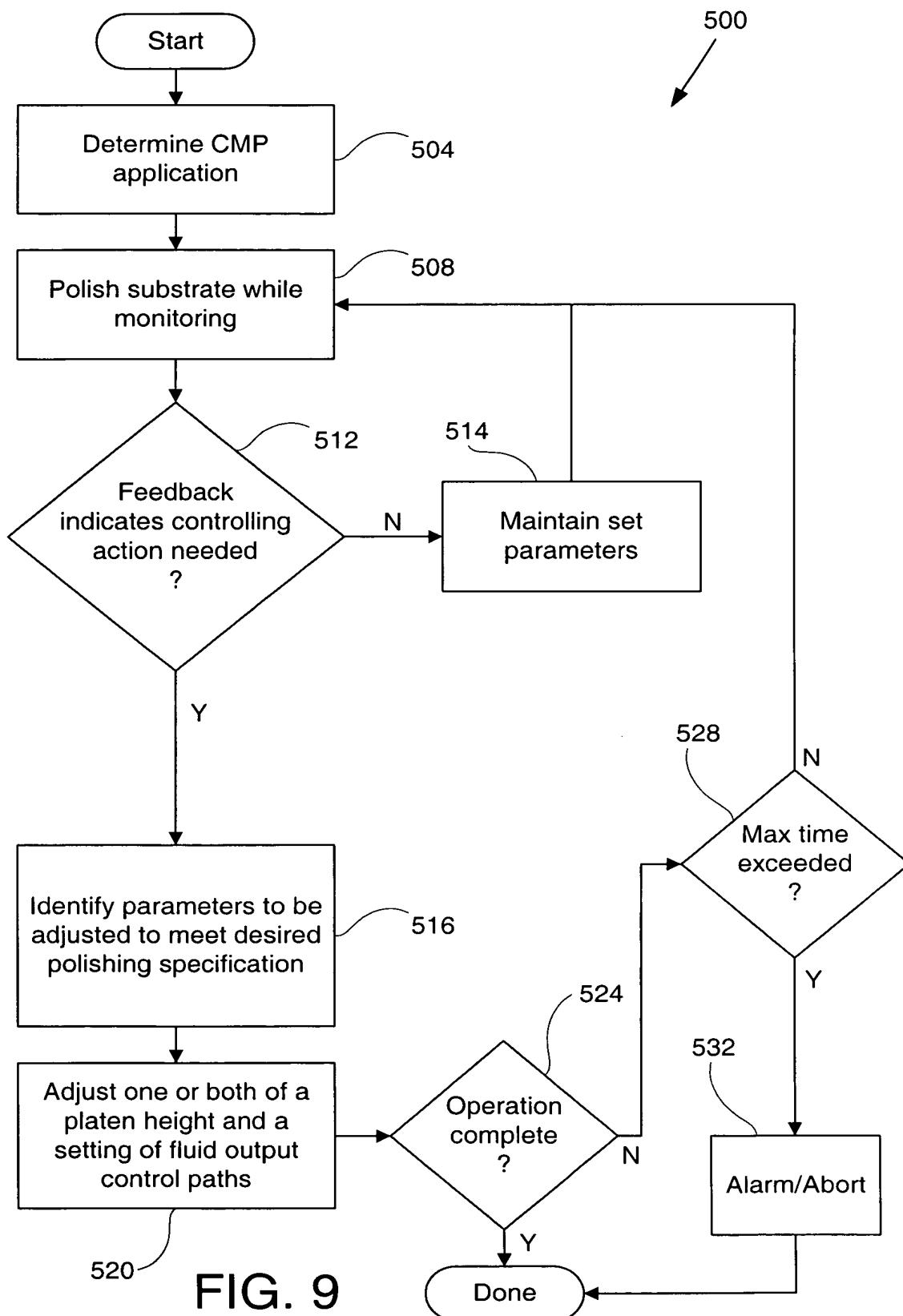


FIG. 9